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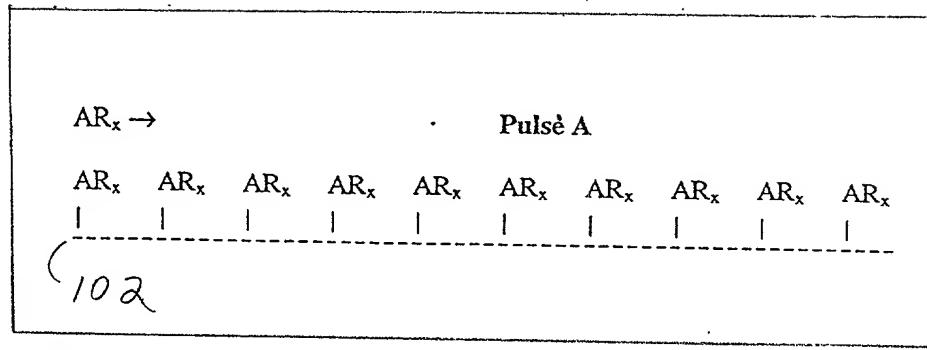


Fig. 1 (Prior Art)

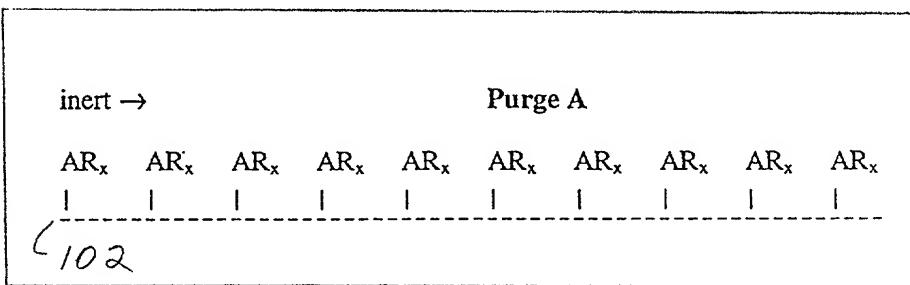
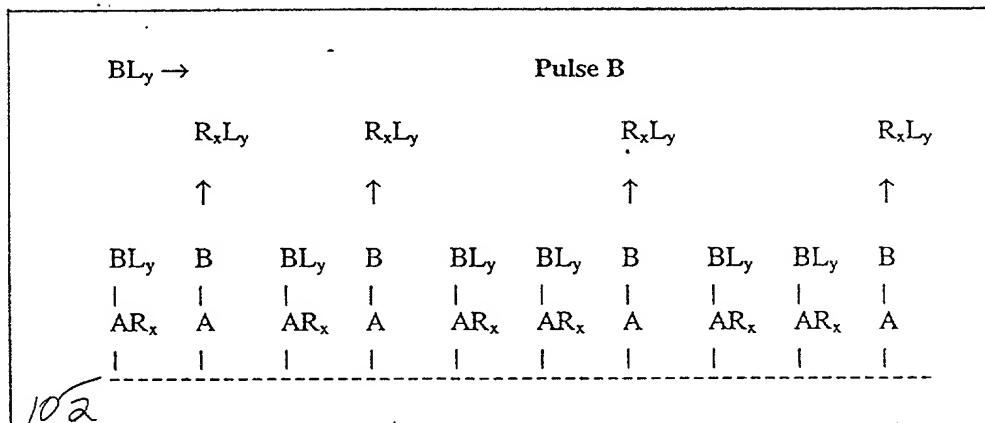


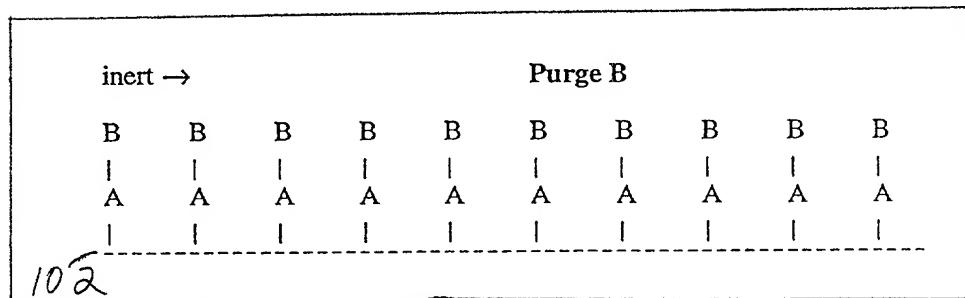
Fig. 2 (Prior Art)

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T
300

Fig. 3 (prior Art)



T
400

Fig. 4 (prior Art)

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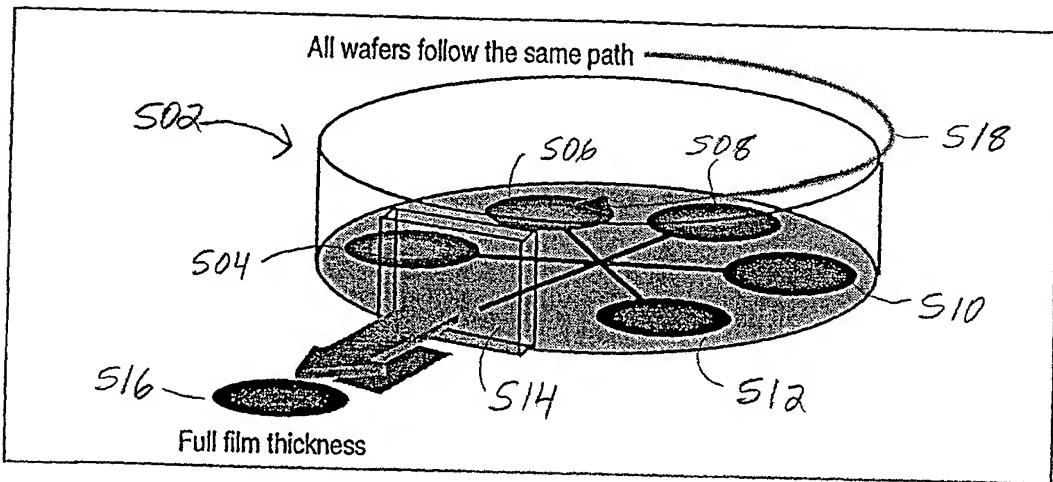


Fig. 5

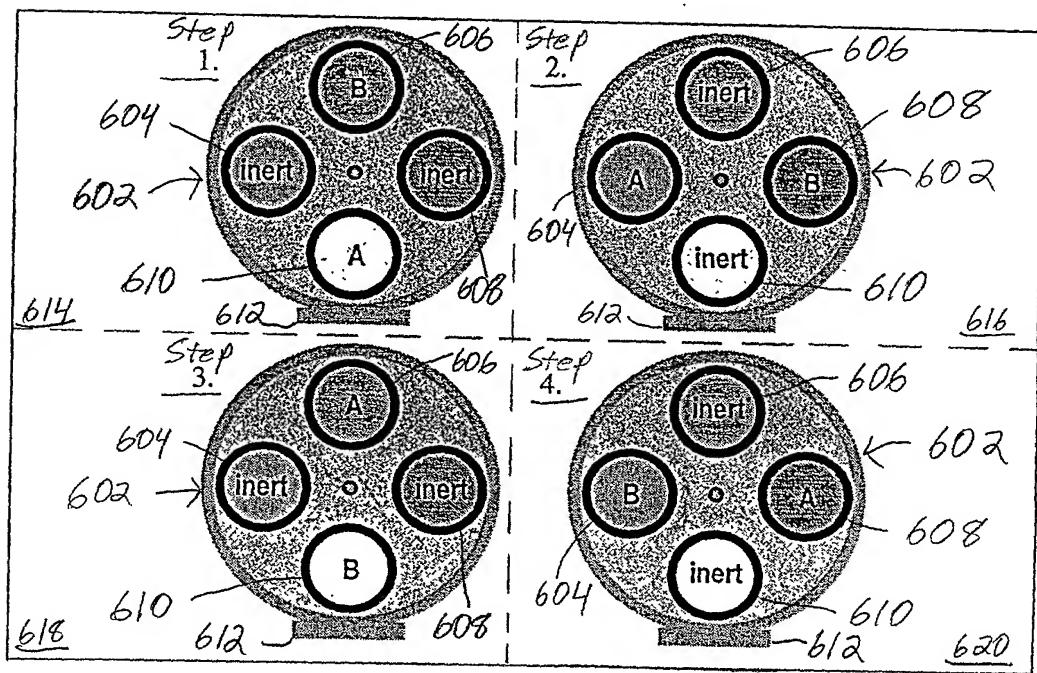


Fig. 6

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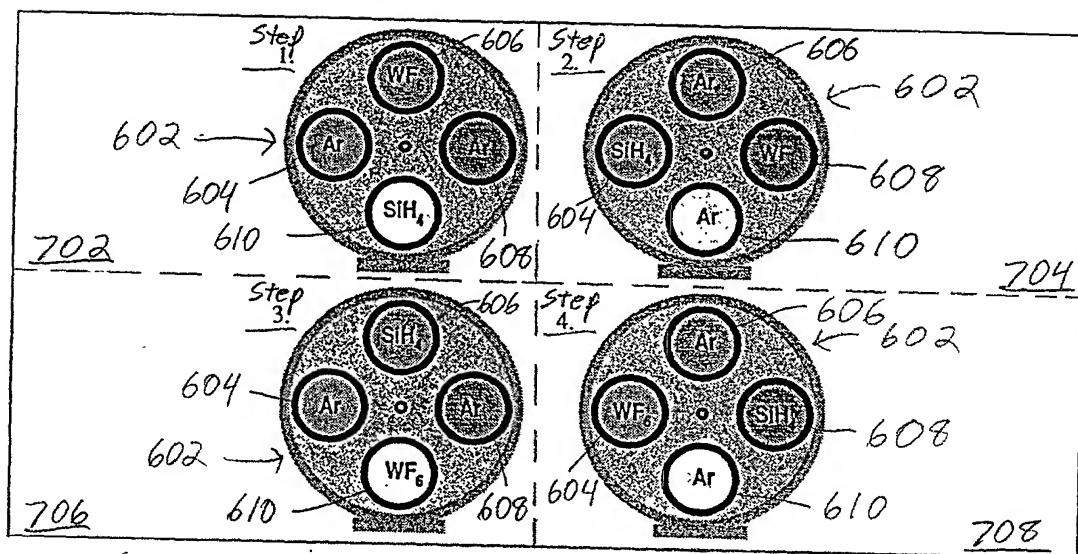


Fig. 7

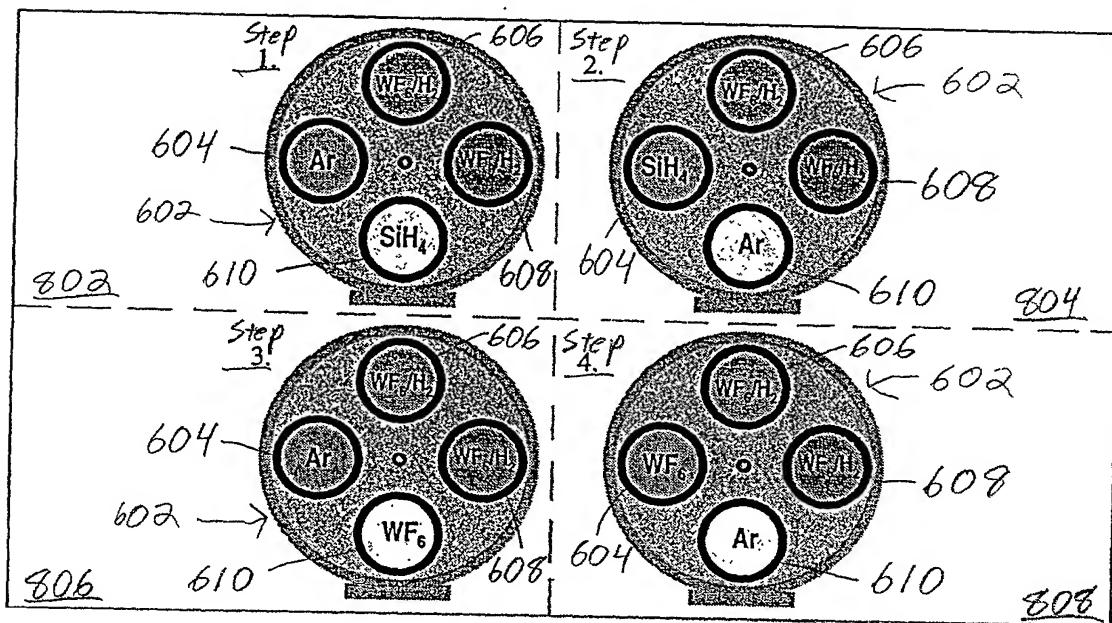


Fig. 8

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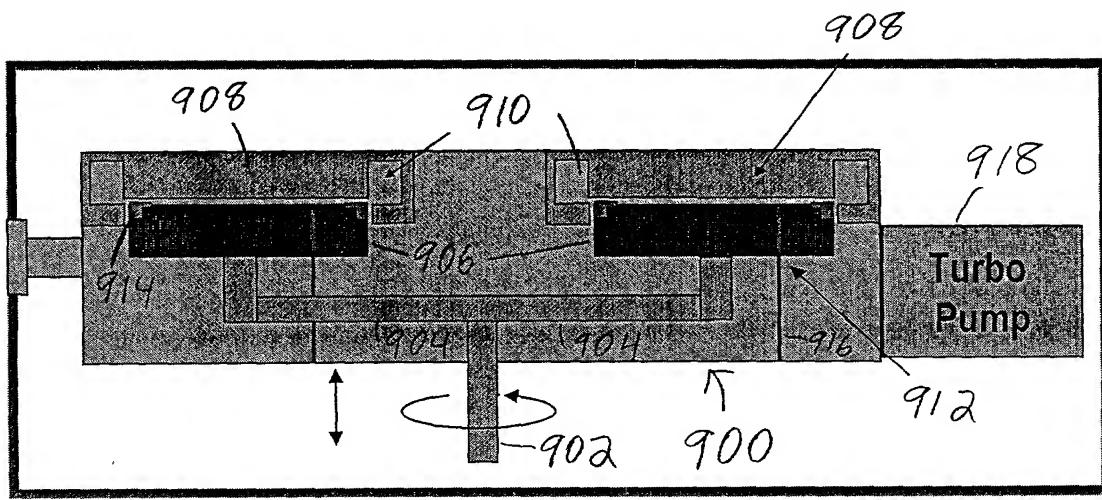


Fig. 9

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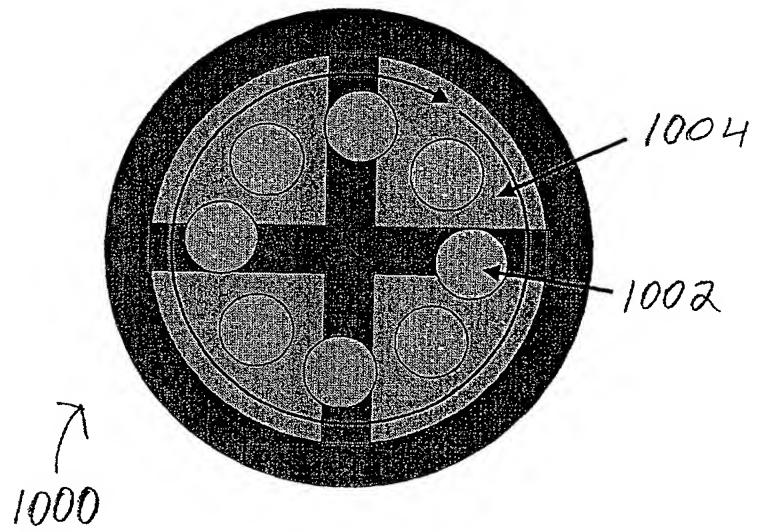


Fig. 10

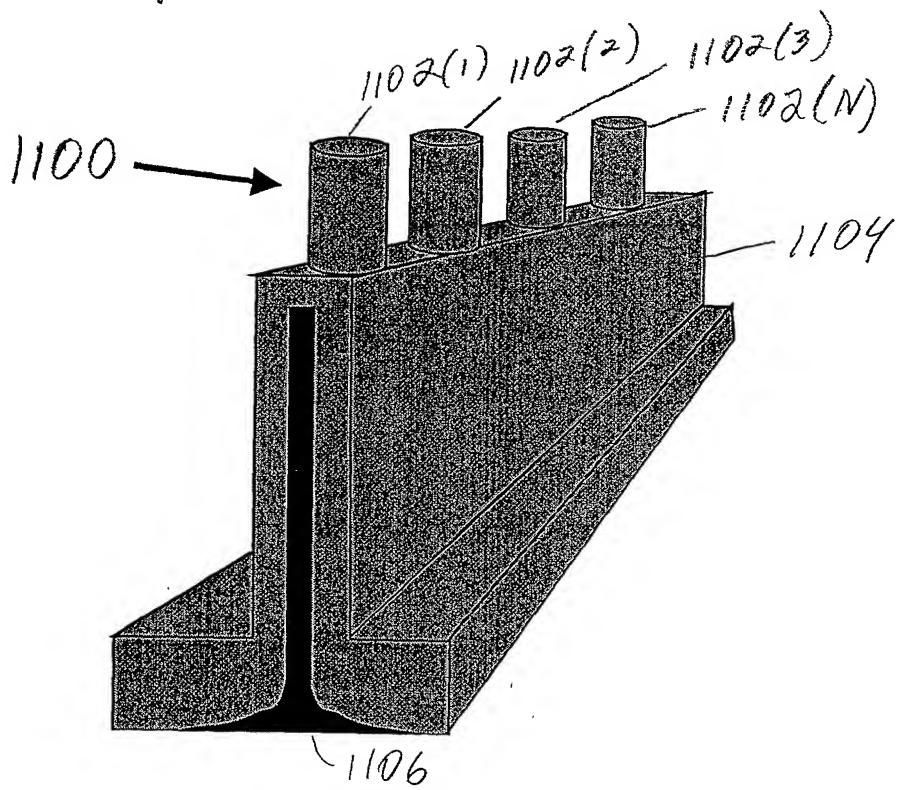


Fig. 11

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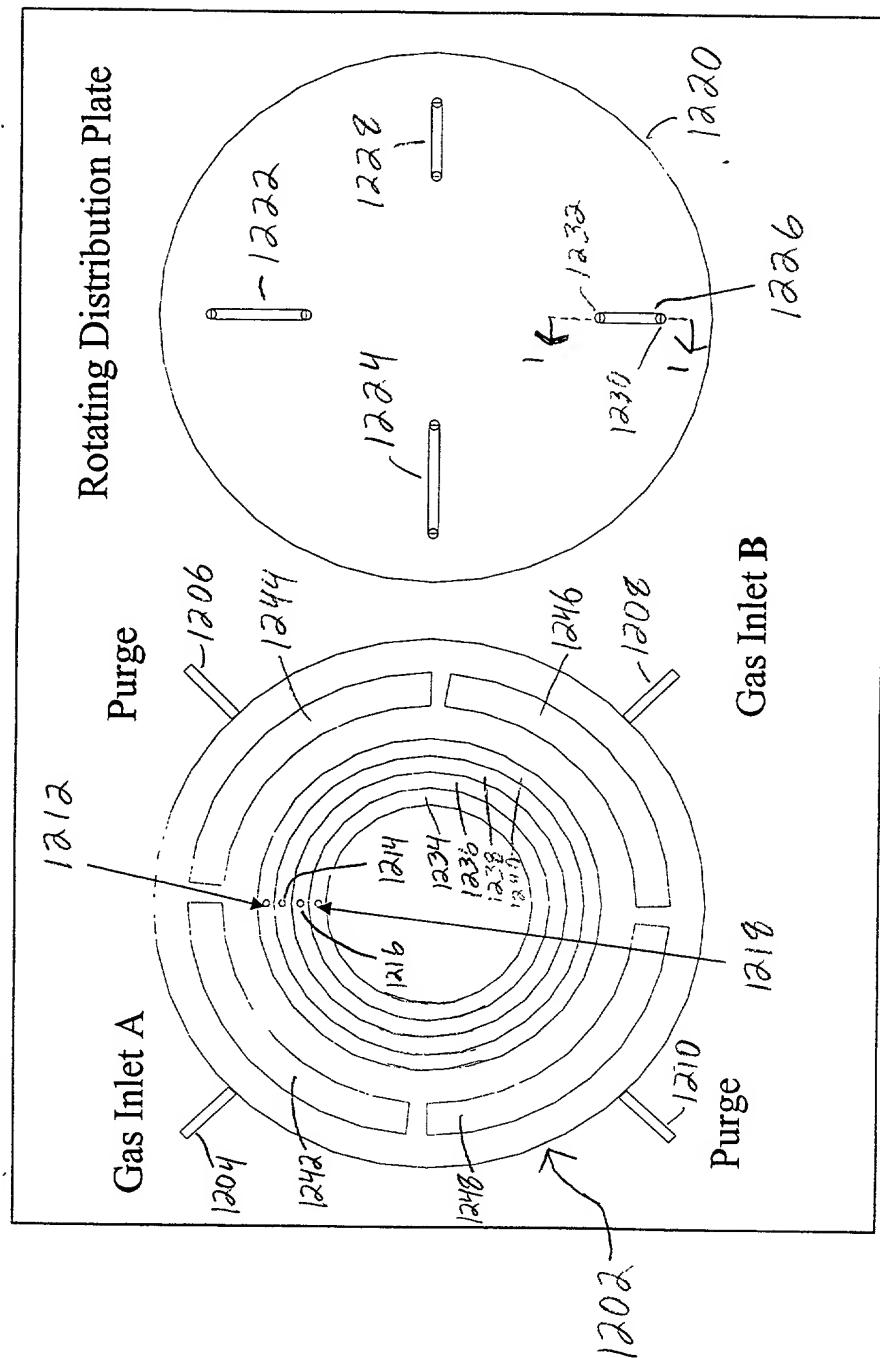


Fig. 12

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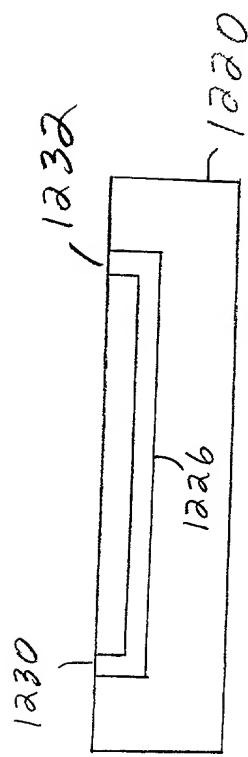


Fig. 13